



PATENT
Customer No. 22,852
Attorney Docket No. 04329.2444-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Hiroshi TOYODA, et al.) Group Art Unit: 2814
Application No.: 10/600,568) Examiner: Weiss, Howard
Filed: June 23, 2003)
For: METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE)
INCLUDING TWO-STEP)
POLISHING OPERATION FOR CAP)
METAL (As Amended Herein))

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action of January 12, 2004, with a period for response extending through April 12, 2004, please amend the application as follows. Applicants also respectfully request the Examiner's reconsideration in view of the remarks that follow:

An Amendment to the Title is shown on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims beginning on page 3 of this paper.

Remarks begin on page 7 of this paper.

AMENDMENT TO THE TITLE:

Please amend the title of the application as follows. On page 1, please replace the title at lines 2 and 3 with the following title:

--METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE INCLUDING
TWO-STEP POLISHING OPERATION FOR CAP METAL AND SEMICONDUCTOR
DEVICE--